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PATENT NUMBER

U.S. UTILITY Patent Application

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APPLICATION NO. CONT/PRIOR CLASS SUBCLASS ART UNIT EXAMINER

09/997484 F 359 2873

Manabu Oumi Susumu Ichihara Kenji Kato Yasuyuki Mitsuoka

Method of fabricating optical aperture and method of fabricating probe for near field light device

PTO-2040

ISSUING CLASSIFICATION							
ORIGIN	AL	CROSS REFERENCE(S)					
CLASS	SUBCLASS	CLASS	SUBCLASS (ONE SUBCLASS PER BLOCK)				
INTERNATIONAL	L CLASSIFICATION						
			Continued on Issue Slip Inside File Jacket				

TERMINAL DISCLAIMER	DRAWINGS			CLAIMS ALLOWED	
	Sheets Drwg.	Figs. Drwg.	Print Fig.	Total Claims	Print Claim for O.G.
The term of this patent subsequent to (date)		<u> </u>		NOTICE OF ALL	LOWANCE MAILED
has been disclaimed.	(Assistant I	Examiner)	(Date)		
The term of this patent shall not extend beyond the expiration date					
of U.S Patent. No.				ISSUE FEE	
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